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APPLICANTS

Pyung-Yong Um, Kyungki-do, KOREA, REPUBLIC OF;  
*HEA*

\*\* CONTINUING DATA \*\*\*\*\*  
 This application is a 371 of PCT/KR03/01915 09/19/2003  
*HEA*

\*\* FOREIGN APPLICATIONS \*\*\*\*\*  
 REPUBLIC OF KOREA 10-2002-0059372 09/30/2002

\*\* SMALL ENTITY \*\*

Foreign Priority claimed 35 USC 119 (a-d) conditions met Verified and Acknowledged	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after <i>Allowance</i> Examiner's Signature: <i>[Signature]</i> Initials: <i>[Initials]</i>	STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS  DRAWING 6	TOTAL  CLAIMS 5	INDEPENDENT  CLAIMS 2
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ADDRESS  
 27667  
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TITLE  
 Method for depositing nitride film using chemical vapor deposition apparatus of single chamber type

FILING FEE  RECEIVED 450	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue )
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